



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/526,800 Confirmation No. 7409  
Applicants : Anatoly L. Vikharev, Aleksey M. Gorbachev,  
Aleksandr G. Litvak, Juriy V. Bykov, Grigory  
G. Denisov, Oleg A. Ivanov and Vladimir A.  
Koldanov  
Filed : March 7, 2005  
Title : HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND  
FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE  
PLASMA AND DEVICE FOR CARRYING OUT SAID  
METHOD  
TC/A.U. : 1792  
Examiner : Rakesh Kumar Dhingra  
Docket No. : IOAP 4.1-1  
Customer No. : 21036

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action mailed March 4, 2009, Applicants amend and remark as follows:

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.